

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Koichi Ohto, et al.	Examiner:	Unassigned
Serial No:	Unassigned	Art Unit:	Unassigned
Filed:	Herewith	Docket:	17408
For:	SEMICONDUCTOR DEVICE, AND PRODUCTION METHOD FOR MANUFACTURING SUCH SEMICONDUCTOR DEVICE	Dated:	January 29, 2004


Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

CLAIM OF PRIORITY

Sir:

Applicants in the above-identified application hereby claim the right of priority in connection with Title 35 U.S.C. § 119 and in support thereof, will submit in due course a certified copy of Japanese Patent Application No. 2004-018079, filed on January 27, 2004 & Japanese Patent Application No. 2003-021076, filed on January 29, 2003.

Respectfully submitted,


Paul J. Esatto, Jr.
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
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Dated: January 29, 2004


Paul J. Esatto, Jr.